

Notice of References Cited	Application/Control No. 10/644,644	Applicant(s)/Patent Under Reexamination HENLEY ET AL.	
	Examiner Hsien-ming Lee	Art Unit 2823	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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	N	JP 7-164728	06-1995	Japan	Takemura et al.	B41M 3/12
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NON-PATENT DOCUMENTS

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